PATENT ASSIGNMENT

Electronic Version v1.1 Stylesheet Version v1.1

SUBMISSION TYPE:	CORRECTIVE ASSIGNMENT
NATURE OF CONVEYANCE:	Corrective Assignment to correct the Assignees' information previously recorded on Reel 016726 Frame 0438. Assignor(s) hereby confirms the Assignment.

CONVEYING PARTY DATA

Name	Execution Date
Osamu ARISUMI	04/20/2005
Yoshinori KUMURA	04/21/2005
Kazuhiro TOMIOKA	05/11/2005
Ulrich EGGER	05/17/2005
Haoran ZHUANG	05/20/2005
Bum-ki MOON	06/01/2005

RECEIVING PARTY DATA

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Street Address:	l, Shibaura 1-chome, Minato-Ku	
City:	Tokyo	
State/Country:	JAPAN	
Postal Code:	105-8001	

Name:	Infineon Technologies AG
Street Address:	StMartin-Str. 53
City:	Munich
State/Country:	GERMANY
Postal Code:	81669

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	11107750

CORRESPONDENCE DATA

Fax Number: (703)413-2220

Correspondence will be sent via US Mail when the fax attempt is unsuccessful.

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PATENT REEL: 022011 FRAME: 0910

500736777

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Address Line 1: 1940 Duke Street

Address Line 4: Alexandria, VIRGINIA 22314

ATTORNEY DOCKET NUMBER: 270998US0SX

NAME OF SUBMITTER: Teresa Pena

Total Attachments: 13

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Atty Docket No.:

270998US



U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office

FORM PTO-1595 06-04

To the Director of the United States Patent and Trademark Office. Please record use and

riginal documents or copy thereof.

1. Name of conveying party(ies):	2. Name and address of receiving party(ies):
Osamu ARISUMI, Yoshinori KUMURA, Kazuhiro TOMIOKA,	Name: KABUSHIKI KAISHA TOSHIBA
Ulrich EGGER, Haoran ZHUANG, Bum-ki MOON	Address: 1-1, Shibaura 1-chome,
Additional name(s) of conveying party(ies) attached? Yes No	Minato-ku, Tokyo 105-8001, Japan
3. Nature of Conveyance:	
Assignment	
☐ Security Agreement ☐ Change of Name	
Other	
Execution Date: April 20, April 21, May 11, May 17, May 20, and June 1, 2005	Additional name(s) and address(es) attached? Yes No
4. Application number(s) or patent number(s):	
☐ This document is being filed together with a new application	
A. Patent Application No.(s)	B. Patent No.(s)
11/107,750	
Additional numbers attach	ed? □ Yes ■ No
5. Name and address of party to whom correspondence concerning document should be mailed:	6. Total applications and patents involved: 1
concerning document should be maned.	
Customer Number	7. Total fee (37 CFR 3.41): \$40.00
22850	■ Enclosed □ Authorized to be charged to deposit account
Tel. (703) 413-3000	8. Deposit account number: 15-0030
Fax. (703) 413-2220	(Attach duplicate copy of this page if paying by deposit account)
DO NOT USE TI	HIS SPACE
9. Statement and signature	
To the best of my knowledge and belief, the foregoing information	is true and correct and any attached copy is a true
copy of the original document.	
Norman F. Oblon Name of Person Signing Sign	stare 6/2305
Name of Person Signing Sign	ature / Date
Registration Number: 24,618	
Total number of pages including	g this cover sheet: 13
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06/24/2005 SPENBOB1 00000074 11107750 01 FC:8021

PATENT

REEL: 022011 FRAME: 0912

In consideration of value received, I, having a residence as stated below above my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are listed below) of an invention described in an application for United States patent entitled:

SEMICONDUCTOR DEVICE AND MASK PATTERN

sell and assign to

- 1. KABUSHIKI KAISHA TOSHIBA, a Japanese corporation, having a business address at 1-1, Shibaura 1-chome, Minato-ku, Tokyo 105-8001, Japan; and
- 2. Infineon Technologies AG, a German corporation, having a business address at St.-Martin-Str. 53, 81669, Munich, Germany

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said United States patent application:

(check one)	[X]	executed concurrently herev	rith		
		executed on Application No. 11/107,7	; 50 , filed <i>p</i>	April 18,	2005

and in and to all applications for patent and patents for invention including all divisions, reissues, continuations, substitutes and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuing, continued prosecution, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention.

I hereby grant the following law firm the power to insert on this Assignment any further identification which may be necessary or desirable in order to comply with the Rules of the U.S. Patent and Trademark Office for recordation of this document.

Oblon, Spivak, McClelland, Maier & Neustadt, P.C., 1940 Duke Street, Alexandria, VA 22314

[1st Inventor]	
Residence Address: Yokohama-shi, Japan	
Mailing Address: c/o Intellectual Property Division, To Minato-ku, Tokyo 105-8001, Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Citizenship: Japan	
Deann Husum	Apr. 20. 2005
Osamu Arisumi	Date:
[2nd Inventor]	
Residence Address: Yokohama-shi, Japan	
Mailing Address: c/o Intellectual Property Division, T	oshiba Corporation, 1-1, Shibaura 1-chome.
Minato-ku, Tokyo 105-8001, Japan	• , , ,
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Yoshinori Humura	Apr. 21.2005
Yoshinori Kumura	Date:
[3rd Inventor]	
Residence Address: Tsukuba-shi, Japan	
Mailing Address: c/o Intellectual Property Division, T	oshiba Corporation, 1-1, Shibaura 1-chome,
Minato-ku, Tokyo 105-8001, Japan	-
Citizenship: Japan	
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Komhiro Tomioka	may 11, 2005
Kazuhiro Tomioka	Date:
[4th Inventor]	
Residence Address: Gewandhausstr.2, 01067 DRES	:DEN
	GMbH: & Co OHG, 1FD P300 Etch, Koenigsbruecke
	sse 180, 01099, Dresden, Germany
- ·	
Ulrich Egger	Date:
[5th Inventor]	
- · · · ·	
Residence Address: New York, 12589, U. S. A. Mailing Address: 6 Libra LN Wallkill, NY 1258	e ii c a
Citizenship: People's Republic of China	,, o. o. n.
Olingonomp- 1 copie a nepublic of Olinia	
Haoran Zhuang	Date:
Havian Diluang	Dave.

APG039248-USA-A (03S0884)

[6th Inventor]

Residence Address: New York 12601, U. S. A.

Mailing Address: 5 Musselman Dr., Poughkeepsie, NY 12601, U. S. A. Citizenship: Republic of Korea

Bum-ki Moon Date:

In consideration of value received, I, having a residence as stated below above my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are listed below) of an invention described in an application for United States patent entitled:

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its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said United States patent application:

(check one)	[X]	executed concurr	ently herewith					
		executed on Application No.	11/107,750	; , filed	April	18,	2005	

and in and to all applications for patent and patents for invention including all divisions, reissues, continuations, substitutes and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuing, continued prosecution, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention.

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Osamu Arisumi	Date:
[2nd Inventor] Residence Address: Yokohama-shi, Japan Mailing Address: c/o Intellectual Property Division, T Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Yoshinori Kumura	Date:
[3rd Inventor] Residence Address: Tsukuba-shi, Japan Mailing Address: c/o Intellectual Property Division, T Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Kazuhiro Tomioka	Date:
[4th Inventor] Residence Address: Gewandhaus A. 01067 Mailing Address: Infineon Technologies Dres den Gm Citizenship: Federal Republic of Germany Koenigs	DRESDEN bHBCo OHG, IFD P300 Etch, bruecker Stasse 180, 01099 Dresden, Germany
Mil Egger	17 May 2005
Ulrich Egger	Date:
[5th Inventor] Residence Address: New York, 12589, U. S. A. Mailing Address: 6 Libra LN Wallkill, NY 125 Citizenship: People's Republic of China	
Haoran Zhuang	Date:

APG039248-USA-A (03S0884)

[6th Inventor]

Residence Address: New York 12601, U. S. A.
Mailing Address: 5 Musselman Dr., Poughkeepsie, NY 12601, U. S. A.
Citizenship: Republic of Korea

Bum-ki Moon	Date:	

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its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said United States patent application:

(check one)	[X]	executed concurr	ently herewith				
		executed on Application No.	11/107,750	; , filed	April	18,	2005

and in and to all applications for patent and patents for invention including all divisions, reissues, continuations, substitutes and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuing, continued prosecution, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention.

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Osamu Arisumi	Date:
[2nd Inventor] Residence Address: Yokohama-shi, Japan Mailing Address: c/o Intellectual Property Division, T Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Yoshinori Kumura	Date:
[3rd Inventor] Residence Address: Tsukuba·shi, Japan Mailing Address: c/o Intellectual Property Division, T Minato·ku, Tokyo 105·8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,
Kazuhiro Tomioka	Date:
	SDEN n GmbH. & Co OHG, 1FD P300 Etch, Koenigsbruecke sse 180, 01099, Dresden, Germany
Ulrich Egger	Date:
[5th Inventor] Residence Address: New York 12589, U. S. A. Mailing Address: 6 Libra LN Wallkill, NY 1258 Citizenship: People's Republic of China	19, U. S. A.
Haoran Zhuang	Date:

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[1st Inventor]

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Osamu Arisumi	Date:			
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Yoshinori Kumura	Date:			
[3rd Inventor] Residence Address: Tsukuba-shi, Japan Mailing Address: c/o Intellectual Property Division, To Minato-ku, Tokyo 105-8001, Japan Citizenship: Japan	oshiba Corporation, 1-1, Shibaura 1-chome,			
Kazuhiro Tomioka	Date:			
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Ulrich Egger	Date:			
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Haoran Zhuang	Date:			

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Citizenship: Republic of Korea

June, 15t, 2005

PATENT REEL: 022011 FRAME: 0924

RECORDED: 12/19/2008